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,	6 4 4 A		Application Number	10/569,763			
/	FORMATION DISCLOSURE		Filing Date	Feb. 23, 2006			
	MAY 1 2 2006 STATEMENT BY APPLICANT		First Named Inventor	Walter Fix			
	1 4 /		Group Art Unit	Not assigned 2823			
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JAG		EP 1 113 502	07-04-2001	Seiko Epson Corporation	Cited in foreign priority application	×
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Examiner Signature Date Considered

*EXAMINER: Initial if reference considered, wheth or of not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. a Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document, s Kind of document by the appropriate symbols as Indicated on the document under WIPO Standard ST.16 if possible. Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number Substitute for form 1449A/PTO Complete if Known **Application Number** 10/569,763 **INFORMATION DISCLOSURE** Filing Date February 23, 2006 STATEMENT BY APPLICANT First Named Inventor Walter Fix **Group Art Unit** Not assigned (Use as many sheets as necessary) **Examiner Name** Net assigned Sheet 2 Attorney Docket Number 411000-146

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JK	133	US-10/344,926	02/12/2004	Adolf Bernds et al.	See Disclosure Statements filed
SK	99	US-10/344,951	02/12/2004	Adolf Bernds et al.	
MC	106	US-10/380,113	09/25/2003	Adolf Bernds et al.	
OK	105	US-10/381,032	02/12/2004	Adolf Bernds et al.	
SAC	108	US-10/433,959	04/01/2004	Adolf Bernds	
316	111	US-10/433,961	04/01/2004	Wolfgang Clemens et al.	
JK	109	US-10/451,108	05/13/2004	Mark Giles et al.	
2K	104	US-10/467,636	11/04/2004	Adolf Bernds et al.	
SK	113	US-10/473,050	05/20/2004	Adolf Bernds et al.	
JK	101	US-10/479,234	12/30/2004	Adolf Bernds et al.	
SAG	100	US-10/479,238	10/20/2004	Adolf Bernds et al.	
1K	115	US-10/492,922	03/03/2005	Erwann Buillet et al.	
JK	114	US-10/492,923	12/23/2004	Wolfgang Clemens et al.	
JK	119	US-10/498,610	09/29/2005	Walter Fix et al.	
JAC	120	US-10/508,640	12/15/2005	Walter Fix et al.	
JAG	121	US-10/508,737	05/19/2005	Adolf Bernds et al.	·
JK	122	US-10/517,750	10/13/2005	Wolfgang Clemens et al.	
JAG	123	US-10/523,216	02/02/2006	Adolf Bernds et al.	
JAL	124	US-10/523,487	N/A	Wolfgang Clemens et al.	
SAC	127	US-10/524,646	N/A	Walter Fix et al.	
JAC	128	US-10/533,756	N/A	Wolfgang Clemens et al.	
244	129	US-10/534,678	N/A	Wolfgang Clemens et al.	
JAK	131	US-10/535,448	N/A	W. Clemens et al.	
JAC	132	US-10/535,449	N/A	Walter Fix et al.	

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JAG	136	US-10/541,815	N/A	Axel Gerit et al.
M	137	US-10/541,956	N/A	Wolfgang Clemens et al.
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JAK	139	US-10/543,561	N/A	Wolfgang Clemens et al.
2144	140	US-10/542,678	N/A	Adolf Bernds et al.
JK	141	US-10/542,679	N/A	Adolf Bernds et al.
DK.	143	US-10/562,989	N/A	Jurgen Ficker et al.
JAC	144	US-10/562,869	N/A	Wolfram Glauert
DK.	146	US-10/569,763	N/A	Walter Fix et al.
SAC	147	US-10/568,730	N/A	Wolfgang Clemens et al.
DIK	- 148	US-10/569,233	N/A	Adolf Bernds et ai.
JAG	149	US-10/570,571	N/A	Clemens et al.
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JAĆ		US-2002/0068392	06-06-2002	Lee et al.	
SK	1	US-2002/0170897	11-21-2002	Hall	
JK		US-2002/0018911	02-00-2002	Bernius et al.	
3KC	·	US-2002/0195644	12-26-2002	Dodabalapur et al.	
SHG		US-2002/025391	02-28-2002	Angelopoulos	
SAG		US-2002/130042	09-19-2002	Stiene	
JAC		US-2003/0112576	06-19-2003	Brewer et al.	
JK.		US-2003/059987	03-27-2003	Siminghaus Henning et al.	
M		US-2004/0002176	0101-2004	Xu	
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SIC		US-3,512,052	12-12-1970	Maciver et al.	
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JAC		US-3,955,098	05-04-1976	Kawamoto	
SAC		US-3,999,122	12-21-1976	Winstel et al.	
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AG		US-4,302,648	11-24-1981	Sado et al.	
SAG		US-4,340,057	07-20-1982	Bloch	
SAC		US-4,442,019	04-19-1984	Marks	
OK		US-4,554,229	11-19-1985	Small	
DK		US-4,865,197	09-12-1989	Craig	
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JAG	US-5,705,826	01-06-1998	Aratani et al.
JK	US-5,173,835	12-22-1992	Cornett et al.
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JK.	US-5,574,291	11-12-1996	Dodabalapur et al.
JK	US-5,578,513	11-00-1996	Maegawa
JAC	US-5,580,794	12-03-1996	Allen
JAK	US-5,625,199	04-29-1997	Baumbach et al.
JAG	US-5,630,986	05-20-1997	Charlton
DKG	US-5,580,794	12-03-1996	Allen
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JK.	US-5,729,428	03-17-1998	Sakata et al.
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aka	US-5,883,397	03-16-1999	Isoda et al.
JAG	US-5,892,244	04-06-1999	Tanaka et al.
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JK	US-5,998,805	12-07-1999	Shi et al.	
JAC	US-6,045,977	04-04-2000	Chandross et al.	
JK	US-6,060,338	05-09-2000	Tanaka et al.	
JAG	US-6,072,716	06-06-2000	Jacobsen et al.	
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JAG	US-6,133,835	10-17-2000	DeLeeuw et al.	
DK!	US-6,150,668	11-21-2000	Вао	
JM	US-6,180,956	01-30-2001	Chondroudis	
)K	US-6,197,663	03-06-2001	Chandross	
JAG	US-6,207,472	03-27-2001	Calligari et al.	
THE	US-6,215,130	04-00-2001	Dodabalapur	
JAG	US-6,221,553	04-24-2001	Wolk	
JK	US-6,251,513	06-26-2001	Rector	
JAC	US-6,284,562	09-00-2001	Batlogg et al.	
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AK.	US-6,329,226	12-11-2001	Jones	
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SAC	US-6,335,539	10-19-1999	Dimitrakopoulos et al.	
JK.	US-6,340,822	01-22-2002	Brown et al.	
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JK		DE 100 58 559	, .	05-29-2002		Interactive Biotech.		•	
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OK		DE 101 17 663		10-17-2002		Samsung SDI Co.			
JK		DE 101 20 686		11-07-2002		Siemens AG	<u> </u>		
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JK		DE 198 51 703		05-04-2000		Institute fur Halbleiterphysik			
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			Group Art Unit	-Not assigned	2823		
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515	EP 0 418 504	03-27-1991	Matsushita	X
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SAC	EP 0 460 242	12-11-1991	Nippon Petrochemicals	×
JAG	EP 0 501 456 A2	09-02-1992	Sony	X
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JK:	EP 0 511 807	11-04-1992	GEC Avery Ltd.	. X
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JAK	EP 0 962 984	12-08-1999	Lucent Technologies	X
JIK.	EP 0 966 182	12-22-1999	LG Electronics	×
SK	EP 0 979 715	02-16-2000	Adolf Illig Maschinenbau	
JR	EP 0 981 165	02-23-2000	Lucent Technologies	X
MC	EP 0 989 614 A2	03-29-2000	Sel Semiconductor	. x
OKC	EP 1 048 912	11-02-2000	Miele & Cie	
JAG	EP 1 052 594	11-15-2000	Sokymat S.A.	
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			Group Art Unit	Not assigned 2823	
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OK	EP 1 224 999 (title page only)	07-24-2002	Sumitomo Heavy Ind.	×
JAG	EP 1 237 207	09-04-2002	Fuji Photo Film Co.	×
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JK	JP 09320760	12-12-1997	Matsushita Electric Ind.	
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JAY	JP 2001085272 (abstract)	03-30-2001	Matsushita Electric Ind.	x
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36	JP 362065477A	03-24-1987	Toshiba	x
	JP 54069392	06-04-1979	Sakamoto Mitsuru	
JK,	JP 54069392 (abstract)	06-04-1979	NEC Corp.	X
JAC	JP 60117769 (abstract)	06-25-1985	Fujitsu Ltd.	
JK-	JP 61001060	01-07-1986	Hitachi Koki	×
JK	JP 61167854	07-29-1986	Murata Mfg. Co. Ltd.	×
JAC	JP 62065472 A	03-24-1987	Toshiba Corp.	×
OHL	WO 00/33063	06-08-2000	Moorlodge Biotech	X
JAG	WO 00/36666	06-22-2000	E Ink Corp.	х
1X	WO 00/79617	12-28-2000	Cambridge University	X
JAC	WO 01/03126	01-11-2001	Regents of U. of CA	×
JAG	WO 01/06442	01-25-2001	Yip	x
JAC	WO 01/08241	02-01-2001	E Ink Corporation	х
JAG	WO 01/15233	03-01-2001	Koninklijke Philips	X

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	STATEMENT BY APPLICANT		First Named Inventor	Walter Fix	
ļ			Group Art Unit	Net assigned	2823
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146	WO 01/17029	03-08-2001	E Ink Corp.		Х
JAC	WO 01/17041	03-08-2001	E Ink Corp.		·x
JK	WO 01/27998	04-19-2001	Koninklijke Philips		X
JK	WO 01/46987	06-28-2001	Plastic Logic Ltd.		
JAZ	WO 01/47044 A2	06-28-2001	Plastic Logic Limited		×
JK	WO 01/47044 A3	08-28-2001	Plastic Logic Limited	-	×
JH4	WO 01/47045	06-28-2001	Plastic Logic		x
JK.	WO 01/73109 A2	10-24-2001	Ivemess Medical		×
38	WO 0/047144 A2	06-03-2004	Siemens	-	
J/K	WO 01/73109 A3	10-24-2001	Ivemess Medical		х
JK	WO 02/05360	01-27-2002	Siemens		
1K	WO 02/065557 A1 abstract	08-22-2002	Siemens	, , , , , , , , , , , , , , , , , , , ,	X
JK	WO 02/071139	09-12-2002	Acreo AB		x
JK	WO 02/071505	09-12-2002	Acreo AB		×
JAC	WO 02/076924	10-03-2002	Nisshinbo Industries		
JK	WO 02/091495	11-14-2002	Coatue Corp.		
JAG	WO 02/095805 A2	11-28-2002	Plastic Logic Limited		X
JK	WO 02/095805 A3	11-28-2002	Plastic Logic Limited		х
386	WO 02/099908	12-12-2002	. Siemens AK		
JK	WO 02/15264	02-21-2002	Siemens AK		
JK	WO 02/19443	03-07-2002	Siemens		
JIK	WO 02/19443 (abstract)	03-07-2002	Siemens		×
JAC	WO 02/29912	04-11-2002	Cambridge University		×
JK	WO 02/43071	05-30-2002	Thin Film Electronics		х
JAK	WO 02/47183	06-13-2002	Siemens		
JK JK	WO 02/47183 (abstract)	06-13-2002	Siemens		х
JK	WO 02/99907	12-12-2002	Siemens		
JK	WO 02/99907	12-12-2002	Siemens		Х
JK	WO 02/091495	11-14-2002	Coatue Corp.		X
JAK	WO 0205361	01-17-2002	3M Innovative Prop.		×
IK	WO 02065557 A1	08-22-2002	Siemens		
JK	WO 03/046922	06-05-2003	Infineon Technologies		
JK	. WO 03/067680	08-14-2003	Canon Kabushikl Kaisha		×
JK	WO 03/069552	08-21-2003	Rafsec Oy		×
JK	WO 03/081671	10-02-2003	Siemens AK		
SI	WO 03/095175	11-20-2003	ZBD Displays Ltd.		

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JAC		WO 04/042837 A2 (title	page only)+	05-21-2004		Siemens		
JK		WO 04/042837 A3 (title	page only)+	05-21-2004		Siemens		
JAK		WO 04/047144 A2 (abs	stract)	06-03-2004		Siemens		X
SK		WO 04/047144 A3		06-03-2004		Siemens		
SK		WO 04/047144 A3 (abs	stract)	06-03-2004		Siemens		X
JK		WO 04/7194 A2		06-03-2004		Siemens		
SK		WO 04/7194 A2 (abstra	act)	06-03-2004		Siemens		Х
JAC		WO 04/7194 A3		06-03-2004		Siemens		
JK		WO 2004/032257		04-15-2004		Leonhard Kurz GmbH		
M		WO 2004/042837		05-21-2004		Siemens AK		
3R		WO 2004/083859		09-30-2004		Platform Diagnostics		
SK	Ī .	WO 93/16491		08-19-1993		Kopin Corp.		X
	 							

JK	WO 04/042837 A3 (title page only)+	05-21-2004	Siemens		
JAK	WO 04/047144 A2 (abstract)	06-03-2004	Siemens		×
SK	WO 04/047144 A3	06-03-2004	Siemens		
314	WO 04/047144 A3 (abstract)	06-03-2004	Siemens		X
JK	WO 04/7194 A2	06-03-2004	Siemens		
SIK	WO 04/7194 A2 (abstract)	06-03-2004	Siemens		X
JAC	WO 04/7194 A3	06-03-2004	Siemens		1
JK	WO 2004/032257	04-15-2004	Leonhard Kurz GmbH		1
TH	WO 2004/042837	05-21-2004	Siemens AK		†
372	WO 2004/083859	09-30-2004	Platform Diagnostics		
JK.	WO 93/16491	08-19-1993	Kopin Corp.		X
316	WO 94/17556	08-04-1994	FCI-Fiberchem		X
JAK	WO 95/06240	03-02-1995	Metrika Laboratories		X
JK	WO 95/31831 (title page only)	11-23-1995	Philips Electronics		X
3/2	WO 96/02924	02-01-1996	Oryx Techn Corp.		×
317	WO 96/19792	006-27-1996	Trustees of Princeton	,	X
11/2	WO 97/12349	04-03-1997	DeRivaz		-
1/4	WO 97/18944	05-29-1997	Gov't of USA		X
JK	WO 98/18156	04-30-1998	Steag Microtech		
SK	WO 98/18156 (abstract)	04-30-1998	Steag Microtech		X
DK.	WO 98/18186 (title page only)	04-30-1998	Erico Lightning		X
SK	WO 98/40930	09-17-1998	Precision Dynamics		X
JAG	WO 99/07189 .	02-11-1999	Cambridge		X
SK	WO 99/10929 (title page only)	03-04-1999	Koninklijke Philips		Х
JK.	WO 99/10939	03-04-1999	Koninklijke Philips		X
JK	WO 99/21233	04-29-1999	Regents of U California		X
SK	WO 99/30432	06-17-1999	Koninklijke Philips		
JK.	WO 99/39373	08-05-1999	Trustees of Princeton University		×
	WO 99/40631	08-12-1999	Opticom USA		X
X	WO 99/53371	10-21-1999	E-Ink Corporation		X
SAC	WO 99/54936	10-28-1999	Cambridge Display		X
346	WO 99/54936 Corrected Version	10-28-1999	Cambridge Display		
SAC	WO 99/66540	12-23-1999	Opticom ASA		×
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			Group Art Unit	Not assigned 2823	
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K		BAO, Z. et al., "High-Performance Plastic Transistors Fabricated by Printing Techniques", Chem. Mater Vol. 9, No. 6, 1997, pp 1299-1301.	
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PK		BRAUN D., et al, "Visible light emission from semiconducting polymer diodes", American Institute of Physics, Applied Physics Letters 58, May 6, 1991, pages 1982 – 1984.	×
AK		BROWN, A.R. et al., "Field-effect transistors made from solution-processed organic semiconductors", Elsevier Science, S.A., Synthetic Metals 88 (1997) pp. 37-55	x
R		BROWN, A.R., "Logic Gates Made from Polymer Transistors and Their Use in Ring Oscillators", Science, Vol. 270, November 10, 1995, pp 972 - 974	x
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M		CHEN, X.L. et al., "Morphological and Transistor Studies of Organic Molecular Semiconductors with Anisotropic Electrical Characteristics", American Chemical Society, 2001, Chem. Mater. 2001, 13, 1341—1348.	x
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She	FICKER, J. et al., "Dynamic and Lifetime Measurements of Polymer OFETS and Integrated Plastic Circuits, "Proc. of SPIE, v. 466, 2001, pp. 95-102	×
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AK	GARNIER F et al:, "Vertical Devices Architecture By Molding Of Organic-Based Thin Film Transistor", Applied Physics Letters, American Institute Of Physics. XP000784120, issn: 0003-6951 abbildung 2	×
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H	GELINCK, G.H. et al., "High-Performance All-Polymer Integrated Circuits", Applied Physics Letters, v. 77, 2000, pp. 1487-1489.	x
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SAK	KLAUK, H. et al., "Fast Organic Thin Film Transistor Circuits", IEEE Electron Device Letters, Vol. 20, no. 6, pages 289-291	х
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	INFORMAT	LION DISCFOS	SE &	Filing Date	Feb. 23, 2006
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				Group Art Unit	Not-accigned 2823
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Examiner Cite No.1		Document Number Publication- Date		Name of Patentee or	Pages, Columns, Lines, Where	
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JK		Sylvie Goncalves-Conto et al. Interface Morphology in Organic Light-Emitting Diodes Adv. Materials 1999, 11, No. 2, pp. 112-115 Wiley-VCH GmbH, D-69469 Weinhein, XP-000877971	

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